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500.42015VX1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Go MIYA et al.  
Serial No.: 10/781,689  
Filed: February 20, 2004  
For: **A DIAGNOSIS METHOD FOR SEMICONDUCTOR  
PROCESSING APPARATUS**  
Group: 1763  
Examiner: Parviz Hassanzadeh

**AMENDMENT**

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**November 12, 2004**

Sir:

In response to the Office Action (Paper No. 06/2004) dated on June 15, 2004,  
please amend the above-identified application as follows.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.

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